

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application of

Examiner: Belyaev

Belouet et al.

Group Art Unit: 1791

Serial No.: 10/584,698

Filed: May 25, 2007

For: A DEVICE FOR DEPOSITING S LAYER OF POLYCRYSTALLINE SILICON  
ON A SUPPORT

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**AMENDMENT**

**SUBMITTED VIA EFS WEB**

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

SIR:

In connection with the above-referenced application, please enter the following amendments and remarks in response to the Office Action dated October 14, 2009.

**Amendments to the Claims** are reflected in the listing of Claims which begins on page 2 of this paper.

**Remarks** begin on page 6 of this paper.